

JAN 09 2003  
 PATENT & TRADEMARK OFFICE

FORM PTO-1449. (REV. 7-80)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. H-961	SERIAL NO. 09/774,723
<b>LIST OF DOCUMENTS CITED BY APPLICANT</b> <i>(Use several sheets if necessary)</i>		APPLICANT T. HIROSE et al	
		FILING DATE February 1, 2001	GROUP <del>2876</del> 2623

**U.S. PATENT DOCUMENTS**

* EXAMINER INITIAL	DOCUMENT	DATE	NAME	CLASS	SUBCLASS	FILING DATE <i>(If Appropriate)</i>
	AA					
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					

**FOREIGN PATENT DOCUMENTS**

DOCUMENT	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
					YES	NO
AL					<input type="checkbox"/>	<input type="checkbox"/>
AM					<input type="checkbox"/>	<input type="checkbox"/>
AN					<input type="checkbox"/>	<input type="checkbox"/>
AO					<input type="checkbox"/>	<input type="checkbox"/>
AP					<input type="checkbox"/>	<input type="checkbox"/>

**OTHER DOCUMENTS** *(Including Author, Title, Date, Pertinent Pages, etc.)*

<u>VB</u>	AR		Doi et al, "SEMICONDUCTOR PLANARIZING CMP TECHNOLOGY" (6 pages: translation of portion believed to be relevant)
	AS		
	AT		

EXAMINER 	DATE CONSIDERED 7/17/03
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\* EXAMINER: Initial if reference considered whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.